Amendments to the Claims

Please amend the claims without prejudice or disclaimer to read as follows:

Claims 1-35 (cancelled).

36 (currently amended). A method for easting forming a thermal barrier coating on a gas-turbine engine having a silicon-based substrate disposed thereon, the method comprising:

depositing a tantalum oxide (Ta_2O_5) layer onto a silicon-based substrate, by electron beam physical vapor deposition, to form a topography such that the tantalum oxide (Ta_2O_5) layer is in the form of columnar grains having gaps therebetween; and

depositing an inorganic layer, by atomic layer deposition, onto the tantalum oxide (Ta₂O₅) layer, such that the inorganic layer is <u>of substantially</u> uniform <u>thickness</u> and <u>is substantially</u> conformal <u>to the topography of the tantalum oxide layer to thereby form said thermal barrier coating on said gas-turbine engine.</u>

37 (original). The method of claim 36, further comprising depositing a bonding coat onto the silicon-based substrate, by atomic layer deposition, before depositing the tantalum oxide (Ta₂O₅) layer.

38 (original). The method of claim 36, wherein the inorganic layer is selected from the group consisting of aluminum oxide (Al₂O₃), tantalum carbide (TaC), hafnium oxide (HfO₂), mixtures thereof, nano-laminates thereof, and alloys thereof.

39 (original). The method of claim 36, wherein the inorganic layer is selected from the group consisting of silicon carbide (SiC), silicon nitride (Si₂N₄), oxycarbides, carbonitrides, mixtures thereof, nano-laminates thereof, and alloys thereof.

40 (original). The method according to claim 36, wherein the silicon-based substrate is one of a silicon nitride substrate and a silicon carbide substrate.

Claims 41-49 (cancelled).

50 (new). The method according to claim 36, wherein the barrier coating preserves the gaps between the columnar grains of the tantalum oxide layer to thereby prevent sintering therebetween.